

INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 11, 2024

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG653410147

LABORATORY GROWN DIAMOND

EMERALD CUT

6.69 X 4.45 X 3.22 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

1.01 CARAT

I

VS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence


VERY GOOD

EXCELLENT

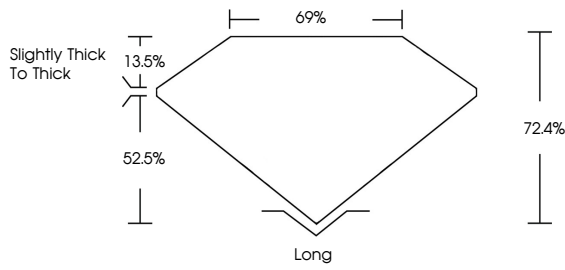
NONE

Inscription(s)

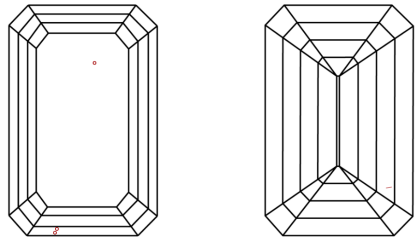
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

 LG653410147

PROPORTIONS



CLARITY CHARACTERISTICS




KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

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
VERY GOOD

EXCELLENT

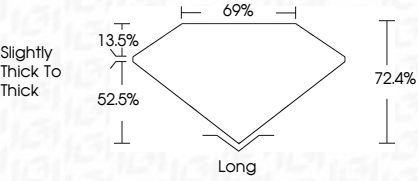
NONE

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PROPORTIONS





COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF VS <sup>1-2</sup> VS <sup>1-2</sup> SI <sup>1-2</sup> I <sup>1-3</sup>

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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EMERALD CUT

6.69 X 4.45 X 3.22 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Slightly Thick To Thick

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

1.01 CARAT

I

VS 1

72.4%


69%

Long

VERY GOOD

EXCELLENT

NONE

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